



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

Inventors: James Lee Hendrix, et al.

Application No.: 10/700,086

Filed: November 3, 2003

For: FLAT SPECTRUM ILLUMINATION  
SOURCE FOR OPTICAL  
METROLOGY

Confirmation No.: 2803

Group Art Unit: 3662

Examiner: Unknown

**CHANGE OF ATTORNEY OR AGENT'S  
ADDRESS IN APPLICATION**

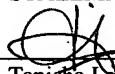
**(37 CFR 1.8(a))**

353 Sacramento Street, Suite 2200  
San Francisco, CA 94111  
(415) 772-4900

**CERTIFICATE OF MAILING**

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope, addressed to: Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450 on May 11, 2004.

STALLMAN & POLLOCK LLP

Dated: 05/11/04 By:   
Tanisha Lawrence-Caceres

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Please send all correspondence for this application to:

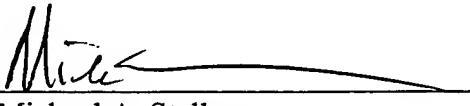
STALLMAN & POLLOCK LLP  
Attn: Michael A. Stallman  
353 Sacramento Street, Suite 2200  
San Francisco, CA 94111

Please direct all telephone calls to:

Michael A. Stallman  
Telephone: (415) 772-4900  
Facsimile: (415) 398-2890

Respectfully submitted,

STALLMAN & POLLOCK LLP

By:   
Michael A. Stallman  
Reg. No. 29,444

Dated: 5/11/04

Attorneys for Applicant(s)